



INFORMATION DISCLOSURE
STATEMENT BY APPLICANT

Complete if Known

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First Named Inventor Richard J. Helferich

Group Art Unit 2684

Examiner Name

Tan H. Trinh Technology Center 2600

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Attorney Docket Number 0101-140

U.S. PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY
		Number	Kind Code ² (if known)		

FOREIGN PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	Foreign Patent Document			Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	T ⁶
		Office ³ Code	Number ⁴	Kind ⁵ (if known)			
	A	KR	00164369	B1	Samsung Electronics Co., Ltd.	September 11, 1998	✓ AB
	B	JP	06318899	A	Dokomo Eng KK Tanaka Masanori	November 15, 1994	✓ AB

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Signature

TRINH, TAN

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2/17/05

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹Unique citation designation number. ²See attached Kinds of U.S. Patent Documents. ³Enter Office that issued the document, by the two-letter code.

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